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Patent Application Serial No. 10/642,454
Filing Date August 13, 2003
Inventor Eugene P. Marsh
Assignee Micron Technology, Inc.
Group Art Unit 2811
Examiner Unknown
Attorney Docket No. MI22-2382
Title: Platinum-Containing Integrated Circuits and Capacitor Constructions

Art Unit 2811
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

1. Certificate of Facsimile Transmission;
2. Supplemental Information Disclosure Statement w/PTO-1449.
3. Copy of 1 cited reference.

Dated: Jan 18, 2005 By: Joanne O'Hare
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Inventor: **Eugene P. Marsh**

Title: **Platinum-Containing Integrated Circuits and Capacitor Constructions**

Assignee: **Micron Technology, Inc.**

Serial No.: **10/642,454**

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the reference listed on the attached Form PTO-1449 and a copy of which is attached. No admission is made regarding whether the submitted reference is prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first Office Action on the merits. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Citation of this reference is respectfully requested.

Respectfully submitted,

Date: 11/18/05

Attorney:


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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2382		SERIAL NO. 10/642,454	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Eugene P. Marsh			
				FILING DATE August 13, 2003		GROUP 2811	
U.S. PATENT DOCUMENTS							
*Examiner's Initials		Document Number	Date	Name		Class	Subclass
	AA						
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
	AJ						<input checked="" type="checkbox"/>
	AK						
	AL						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AM	Nasu, T. et al., "Study of Pt Bottom Electrodes Using High-Temperature Sputtering for Ferroelectric Memories with SrBi ₂ Ta ₂ O ₉ (SBTO) Film", Jpn. J. Appl. Phys. Vol. 37, Part 1, No. 7 (July 1998), pp. 4144-4148.					
	AN						
	AD						
EXAMINER		DATE CONSIDERED					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							